

Docket No.: 65933-046

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Tatsuhiko KOIDE	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: September 25, 2003	:	Examiner: Unknown
	:	
For:		SEMICONDUCTOR DEVICE PROVIDED WITH A DIELECTRIC FILM INCLUDING POROUS STRUCTURE AND MANUFACTURING METHOD THEREOF

**CLAIM OF PRIORITY**

Mail Stop CPD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:


**Japanese Patent Application No. 2002-287672, filed September 30, 2002**

**Japanese Patent Application No. 2003-307807, filed August 29, 2003**

cited in the Declaration of the present application. Certified copies will be filed in due course

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
Arthur J. Steiner  
Registration No. 26,106

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 AJS:tlb  
Facsimile: (202) 756-8087  
**Date: September 25, 2003**